

Confirmation no. 3423

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DE BOER	Examiner:	Lund, J.
Serial No.:	10/537,363	Group Art Unit:	1792
Filed:	June 2, 2005	Docket No.:	US020527US (NXPS.441PA)
Title:	SYSTEM AND METHOD FOR SUPPRESSION OF WAFER TEMPERATURE DRIFT IN COLD-WALL CVD SYSTEMS		

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Customer No.

**65913**

1. This is a request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.
2. Attached please find:
  - a. ☒ An Amendment with Request for Continued Examination, submitted herewith to advance the above-referenced patent application under a final rejection dated January 27, 2010.
3. Fees:
  - a. ☒ Please charge Deposit Account Number 50-4019 (US020527US) the below RCE filing fee, with authorization to charge/credit said deposit account any additional required claims fees/overages to complete this filing.
    1. ☒ **The RCE filing fee \$810.00.**

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